

Wrocław University of Technology



In-situ monitoring of high doses of radiation

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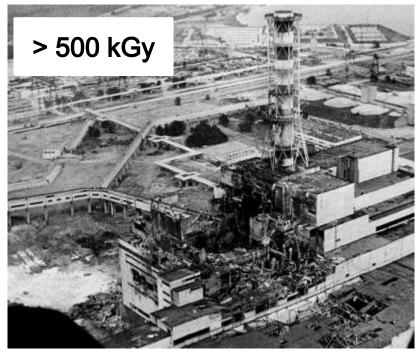
Faculty of Microsystem Electronics and Photonics Division of Microengineering and Photovoltaics

RESMM 2014 Wrocław, Poland, 13 May 2014



Motivaton

Chernobyl (at left) and Fukushima (at right) nuclear power plants after nuclear accidents.





High radiation > 100 kGy doses in short term.



Motivaton

Scientyfic / industy facility



Radiation level - low, but long-term dose high > 20 kGy.



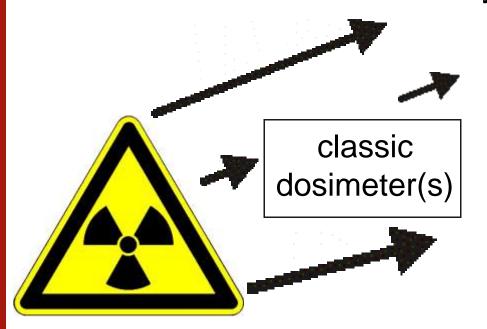
High radiation doses "measurements" - state of art:

- > 20 kGy only non-direct measurements by:
- alanine dosimeters:
- range of measurement up to 1 MGy
- photoluminescent dosimeters:
- range of measurement up to 1 MGy
- thermoluminescent dosimeters:
- range of measurement up to 1 MGy
- hydrogen pressure dosimeters:
- range of measurement up to 10 MGy



Non-direct measurement

absorbed dose above 20 kGy



classic dosimeter(s)

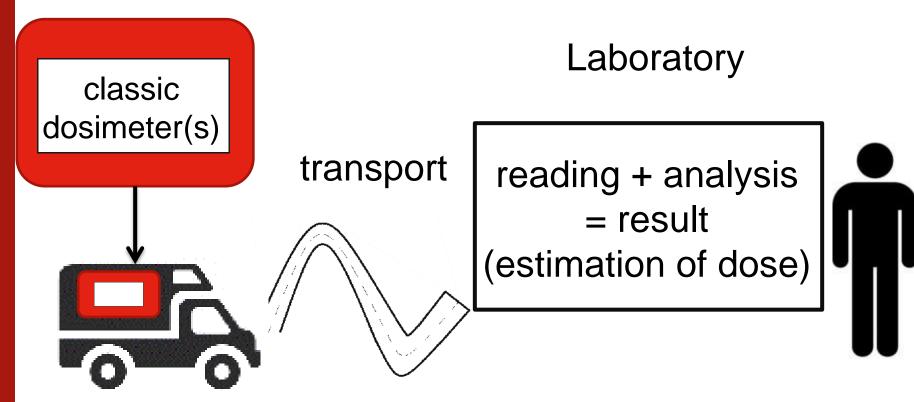
radiation-proof container

radiation source

transport to the laboratory



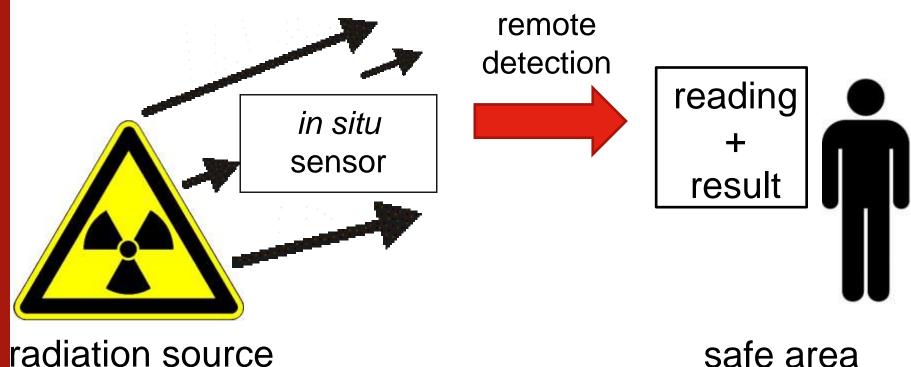
Non-direct measurement



Result: several hours to months



Wanted: new method of measurements of high-doses of radiation above 20 kGy



Problem: no sensors

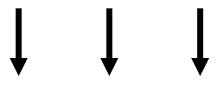


Hydrogen pressure dosimeter - principle of the work

transport

principle using from 1950's

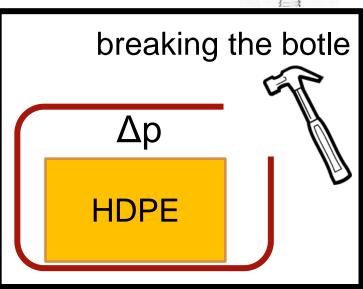
high dose radiation



High Density
Polyethylene
(HDPE)

glass container with HDPE

Laboratory



measurements by Bourdon gauge

Our goal

principle using from 1950's

new MEMS sensor for continues measurements

 H_2 Δp

miniaturization





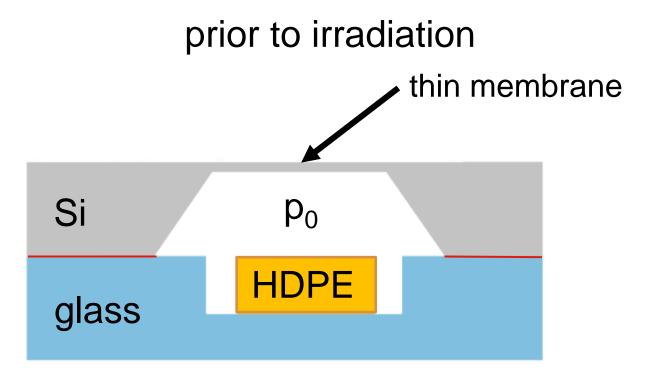
glass container with HDPE

 $V \sim 100 \text{ cm}^3$

 $V \sim 10 \text{ mm}^3$



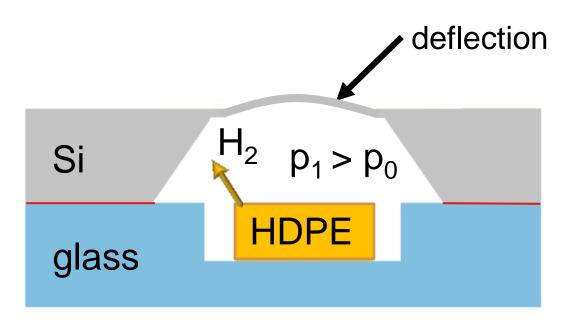
Our new MEMS sensor - principle



 p_0 = introductional pressure (after sealing)

Our new MEMS sensor - principle

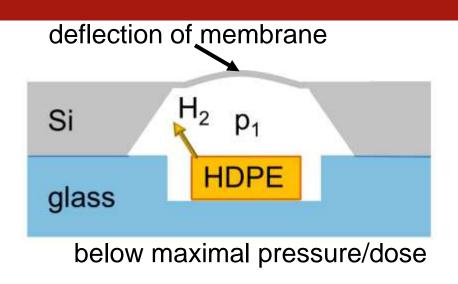
after irradiation

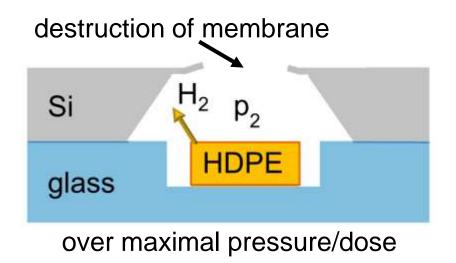


Irradiated HDPE degrades and releases atomic hydrogen

$$p_1 - p_0 = \Delta p = f (dose)$$

Our new MEMS sensor - principle





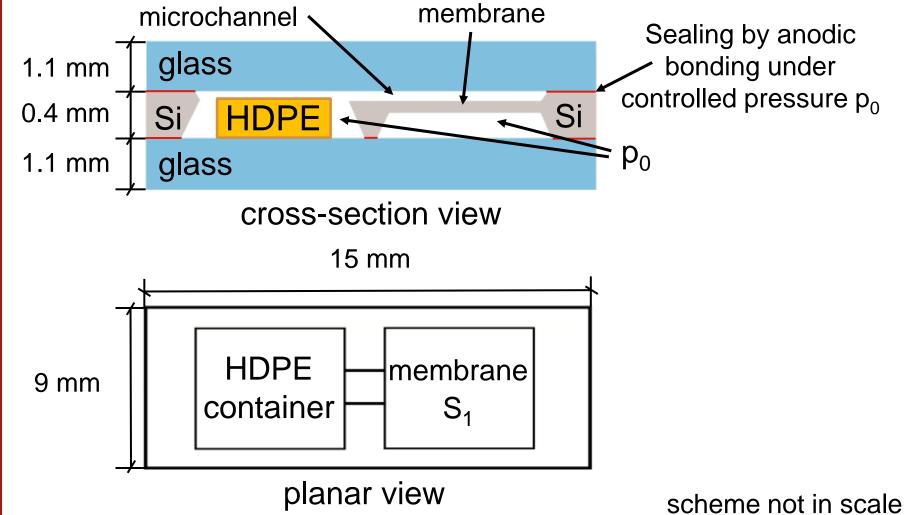
"Cascade" membranes sensor

$$p_2 > p_{max}$$

membrane of known mechanical properties discriminates doses

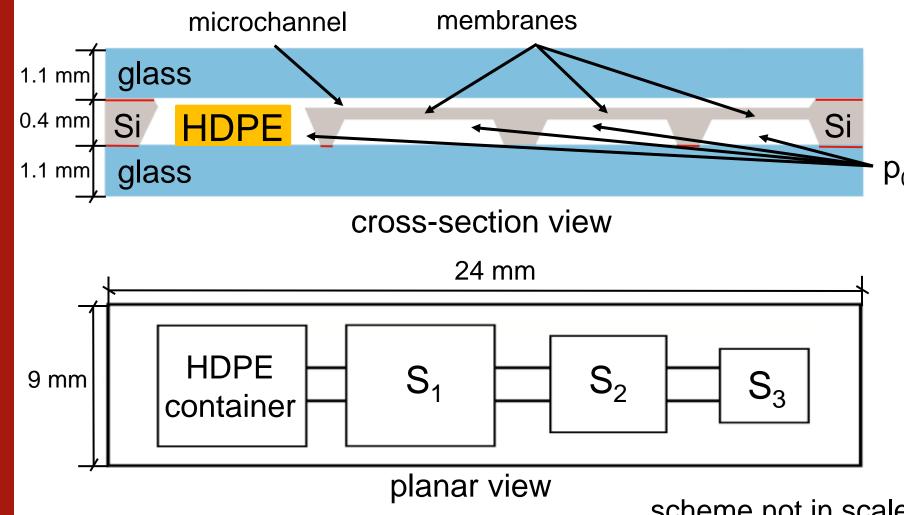


Technical realization Single membrane proportional sensor





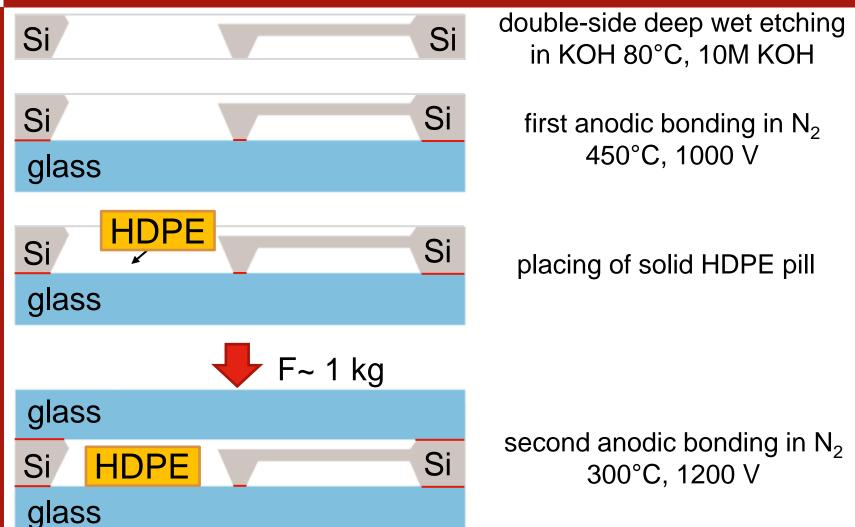
Technical realization "Cascade" membranes treshold sensor



scheme not in scale



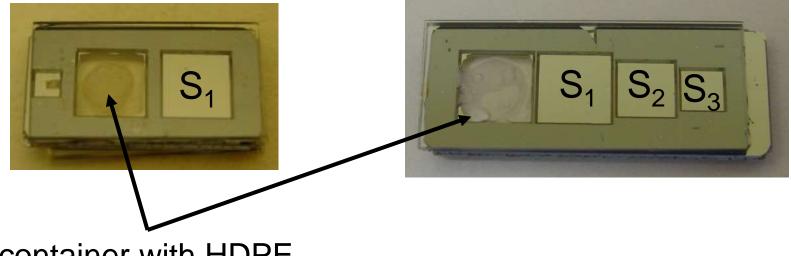
Fabrication - process



MEMS sensors at a glance

Single membrane sensor

"Cascade" membranes sensor

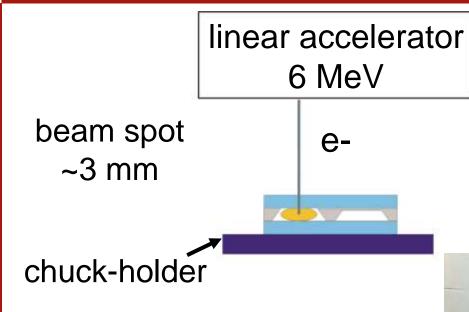


container with HDPE

Several tens of sensors have been successfully fabricated.



Irradiation



total dose 20 kGy < x < 120 kGy

cap accelerator

sample chuck-holder

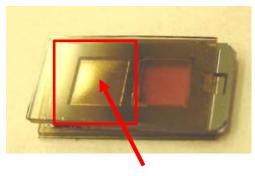
high energy electron beam



Results of irradiation

Single membrane proportional sensor sensor before irradiation sensor after irradiation





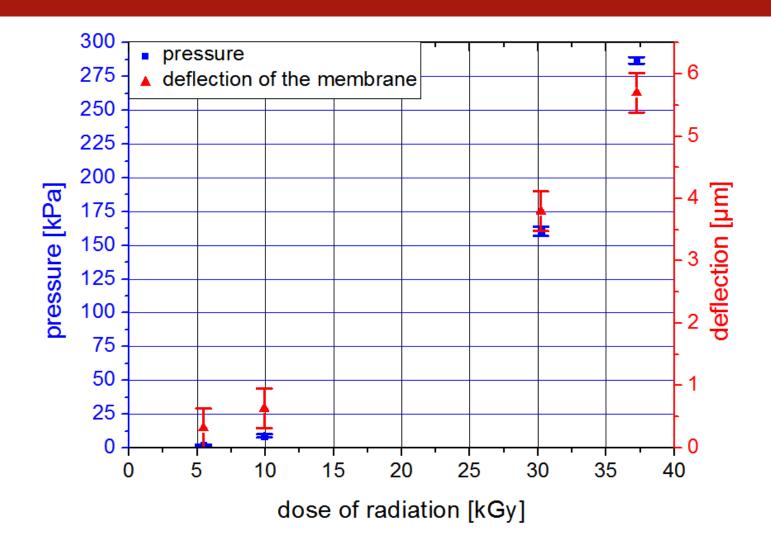
deflected membrane

25 mm² and 30 µm thick membrane – deflected @ 10 kGy dose

Sensors have been fabricated in MEMSlab facilities at Wrocław University of Technology.

Sensors have been tested in National Center for Nuclear Research in Otwock / Świerk

Data processing toward sensor





Results of irradiation

"Cascade" membranes treshold sensor sensor before irradiation sensor after irradiation

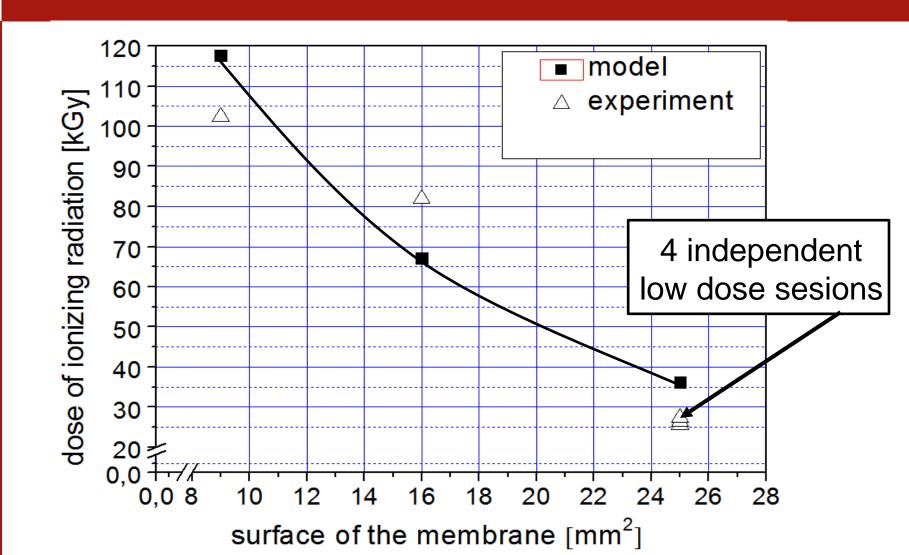




destroyed membrane

25 mm² / 30 µm thick membrane – destroyed at 26.8 kGy dose

Data processing toward sensor



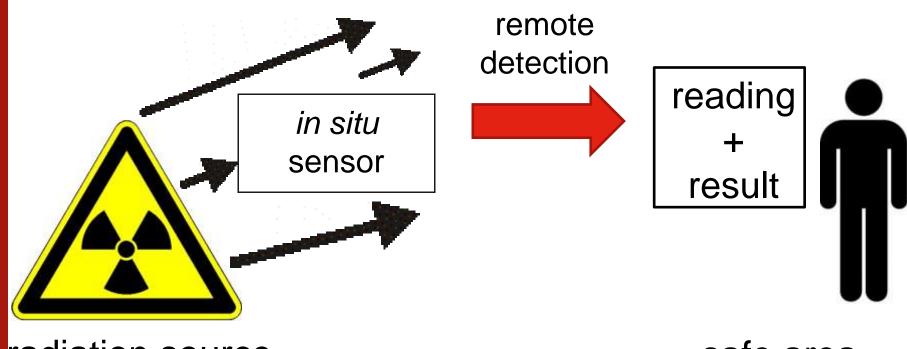


Short interim summary:

- MEMS miniature sensors for detection of high doses of ionizing radiation have been fabricated and tested
- Doses up to 120 kGy have been successfully detected
- High radiation doses 10 120 kGy in situ detection by small MEMS sensor have been shown for the first time
- "Cascade" membrane sensor as dose treshold sensor is ready-to-use!



Single membrane sensor - proportional operation mode



radiation source

safe area

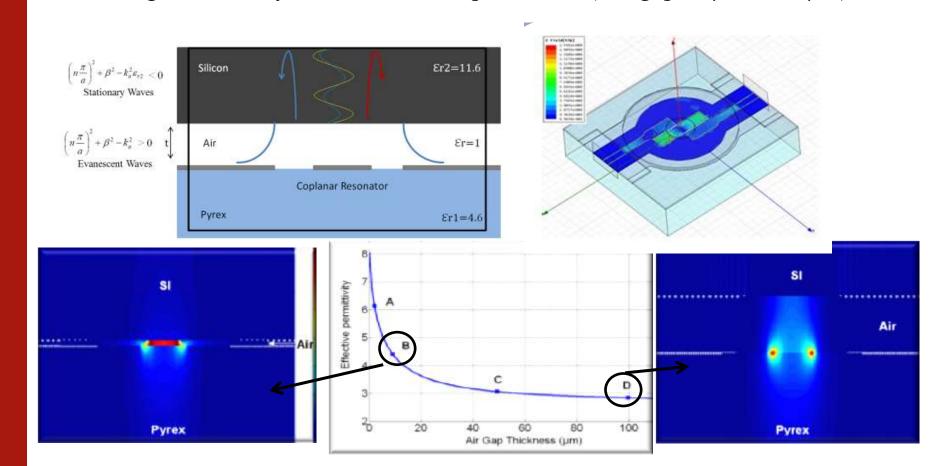
Remote detection



Radar remote detection based on LAAS technology

Modification of EM coupling between resonator and silicon membrane

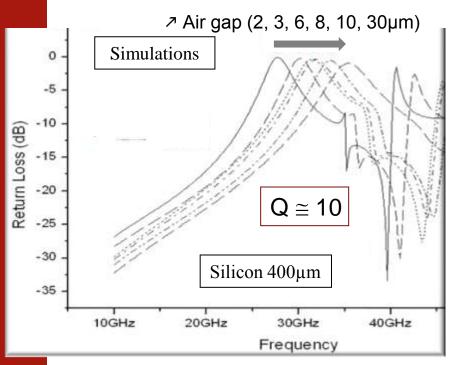
- High sensitivity to membrane displacement (Air gap : 1μm to 10μm)

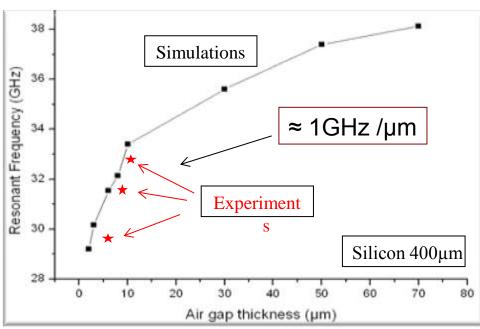






Radar remote detection based on LAAS technology

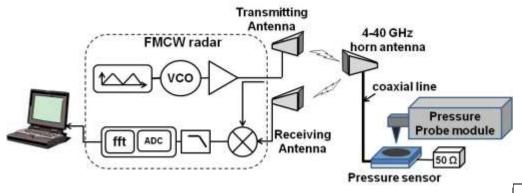


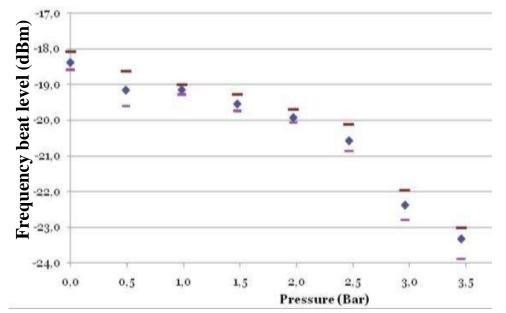




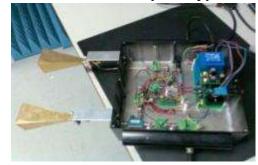


Radar remote detection based on LAAS technology





30GHz Radar prototype



Interrogation distance:

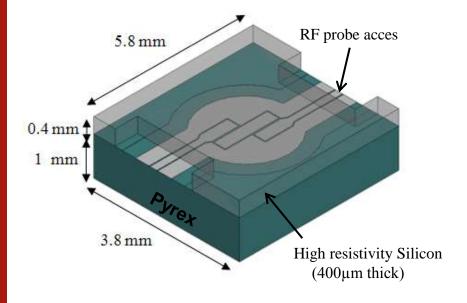
- 3 m (pressure sensor)
- 30m (Antenna loaded with impedance)
 - \rightarrow >> 30m expected

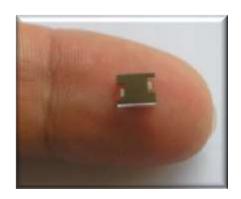


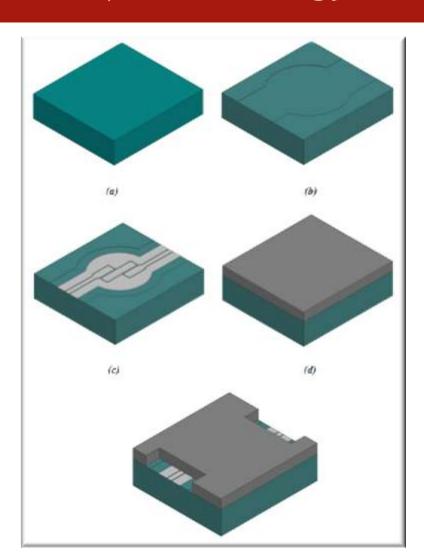




Radar remote detection based on CNRS-LAAS (Toulouse, Fance) technology









MEMS high-dose radiation sensor

DOSIMEMS Project "Passive, wireless MEMS dosimeter for the high radiation dose monitoring", financed by the European Commission under the Seventh Framework Programme FP7, MNT-ERA.NET.











Responsible for development of the sensor technology

DOSIMEMS project- participants

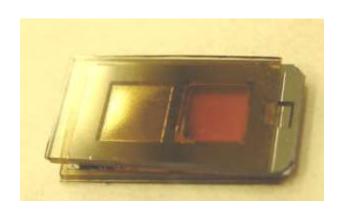


"Cascade" membranes treshold sensor

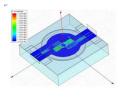


+ simple eye controll

Single membrane proportional sensor



+ remote controll



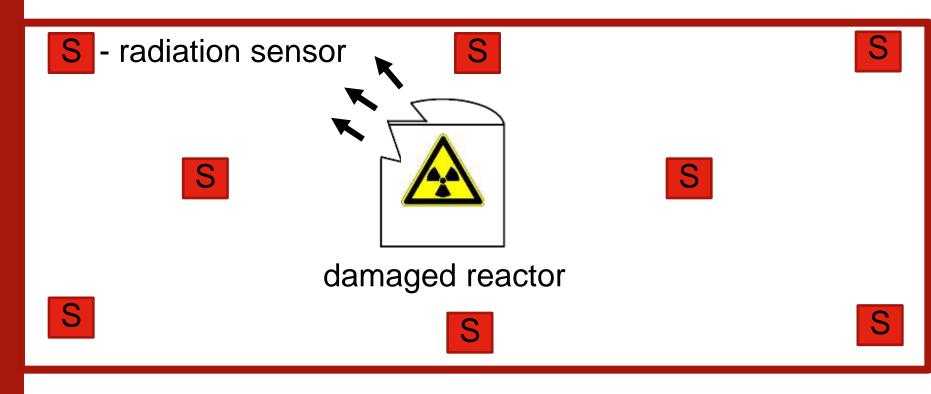


Radar

Optical

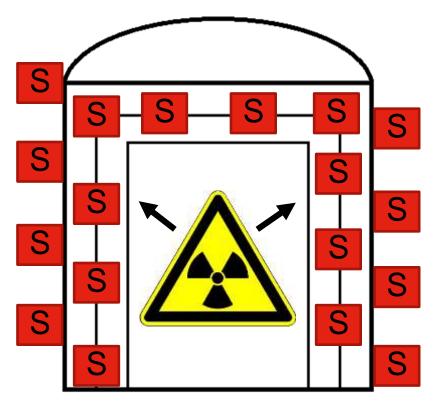


Monitoring of high doses of radiation after the disaster in harsh environment.



polluted area

Monitoring of high doses of radiation acting on the reactor covers – safety "caps".

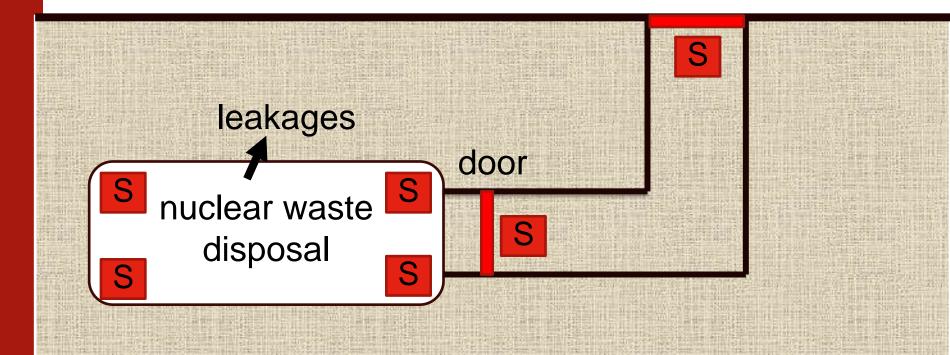


working reactors / industry facility



Monitoring of doses coming from nuclear waste disposal.

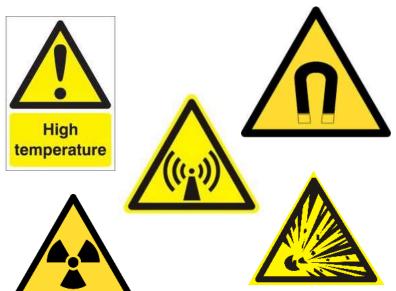
ground door





High radiation coexist with another treats

- High temperature
- High electromagnetic / magnetic field
- Explosion risk
- Poisonous gases



Sensor and sensing head are:

- resistant against high temperature (up to 300 °C)
- EX standard ready
- wireless



More information in papers

- I. Augustyniak, P. Knapkiewicz, J. Dziuban, M. Olszacki, P. Pons, MEMS high-doses radiation sensor, The 17th International Conference on Solid-State Sensors, Actuators and Microsystems, **Transducres 2013**, Barcelona, 16-20 June 2013, p. 1503-1506, ISBN 978-1-4673-5981-8,
- M. Olszacki, M. Matusiak, I. Augustyniak, P. Knapkiewicz, J. Dziuban, P. Pons and E. Debourg, Measurement of the high gamma radiation dose using the MEMS based dosimeter and radiolisys effect,, 24th Micromechanics and Microsystems Europe Conference, September 1-4, 2013 Hanasaari Finland, p. 33-36,

Acknowgelements





MEMSlab Team





www.memslab.pl



MEMSlab team of Faculty of Microsystem Electronics and Photonics of Wroclaw University of Technology – picture taken in the 14th century Castle, Ryn, Poland